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Sheet 1 of 1

FORM PTO-1449	Docket Number (Optional)	Application Number
INFORMATION DISCLOSURE CITATION IN AN APPLICATION	YOR9200010217US2	10/692065 Not yet assigned
(Use several sheets if necessary)	Applicant: Magerlein et al.	
	Filing Date: Concurrently herewith	Group Art Unit: Not yet assigned 2818

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
DJ	6,339,024	1/15/02	Petrarca et al.	438	686	
	6,344,125	2/5/02	Locke et al.	205	118	
	6,368,484	4/9/02	Volant et al.	205	220	
	6,137,185	10-2002	Ishino et al.	257	786	
	6,373,273	04-2002	Akram et al.	324	765	
DJ	5,808,360	09-1998	Akram et al.	257	738	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES	Translation NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

DJ	Richard Volant, Kevin Petrarca, Peter Locke, James A. Tornello and Donald F. Canaperi, Tittle: ***"Replated Metal Structures for Semiconductor Devices"***, U.S. Patent application Serial No. 09/657,469, filed on May 9, 2000.

EXAMINER: DJ

DATE CONSIDERED: 7/28/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

1